Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	280059	semiconductor near substrate	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/11/13 17:32
L2	18039	crystalline near2 layer	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/11/13 17:33
L3	131762	(planariz$3 or smooth) near surface	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/11/13 17:34
L4	606	lattice-mismatch$3	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/11/13 17:35
L5	16	l1 and l2 and l3 and l4	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/11/13 17:35